



Appl. No. 09/473,391  
Amdt. dated May 16, 2003  
Reply to Office Action of February 21, 2003

#20/E  
12  
5/27/03

42390.P8136

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:

Kenneth C. Cadien et al.

U.S. Serial No: 09/473,391

Filed: December 28, 1999

For: ABRASIVES FOR CHEMICAL  
MECHANICAL POLISHING

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Conf. No.: 9927

Examiner: Chen, Kin Chan

Art Unit: 1765

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**AMENDMENT AND RESPONSE**

Dear Sir:

This is in response to the Office Action mailed February 21, 2003. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

**FIRST CLASS CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

on May 16, 2003

Date of Deposit

Claire Wallters

Name of Person Mailing Correspondence

*Claire Wallters*

Signature

5/16/2003

Date